

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION <small>(use several sheets if necessary)</small></p> <p style="text-align: center;">SEP 17 2003</p> <p style="text-align: center;">TRADEMARKS & PATENTS</p>				Docket Number (Optional) KS-4316US	Application Number 10/608,922			
				Applicant(s) Kragl, Hans				
				Filing Date June 27, 2003	Group Art Unit 2874 Not Yet Known			
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
Aulah		6,504,107	1/7/03	Hans Kragl				
		6,004,046	12/21/99	Sosaku Sawada				
		4,945,400	7/31/90	Greg E. Blonder et al.				
		5,987,202	11/16/99	Werner Gruenwald et al.				
		5,434,939	7/18/95	Kenichi Matsuda				
		5,349,234	9/20/94	William F. DesJardin et al.				
		5,737,467	4/7/98	Takeshi Kato et al.				
		5,660,461	8/26/97	Ronald W. Ignatius et al.				
		6,070,315	6/6/00	Klaus Schubert et al.				
		5,675,678	10/7/97	Wolfgang Neuberger et al.				
	5,028,110	7/2/91	William T. Plummer					
FOREIGN PATENT DOCUMENTS							Translation	
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
Aulah		DE 38 24 395 C2	11/16/89	Germany				✓
		DE 33 39 189 A1	5/9/85	Germany				✓
		DE 198 52 832 A	5/25/00	Germany				✓
		WO 98/26885	6/25/98	PCT				✓
		DE 198 51 265 A	5/18/00	Germany				✓
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
Aulah		Kragl, H. et al., "Microstructured three-dimensional printed circuit boards: a novel fabrication technology for optical transceiver modules," Proceedings, MICRO.tec 2000; VDE World Microtechnologies Congress; Vol. 1, pp. 107-110. <i>(CNO date)</i>						
		Kragl, H. et al.: MICROMID: A low cost fabrication technology for polymer fiber transceiver modules. POF Conference 2000, Boston, U.S.A.						
EXAMINER	Akram E.ullah			DATE CONSIDERED	Dec 08/2003			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

<p style="text-align: center;">P INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> <p style="text-align: center;">SEP 11 2003</p> <p style="text-align: center;">U.S. PATENT DOCUMENTS</p>				Docket Number (Optional) KS-4316US	Application Number 10/608,922																																																				
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<p style="text-align: center;">FOREIGN PATENT DOCUMENTS</p> <table border="1"> <thead> <tr> <th rowspan="2">REF</th> <th rowspan="2">DOCUMENT NUMBER</th> <th rowspan="2">DATE</th> <th rowspan="2">COUNTRY</th> <th rowspan="2">CLASS</th> <th rowspan="2">SUBCLASS</th> <th colspan="2">Trendline</th> </tr> <tr> <th>YES</th> <th>NO</th> </tr> </thead> <tbody> <tr> <td></td> <td>DE 196 02 079 C1</td> <td>5/15/97</td> <td>Germany</td> <td></td> <td></td> <td></td> <td>✓</td> </tr> <tr> <td></td> <td>DE 195 42 658 A1</td> <td>5/22/97</td> <td>Germany</td> <td></td> <td></td> <td></td> <td>✓</td> </tr> <tr> <td></td> <td>WO 00/28362</td> <td>5/18/00</td> <td>PCT</td> <td></td> <td></td> <td></td> <td>✓</td> </tr> <tr> <td></td> <td>WO 96/22177</td> <td>7/25/96</td> <td>PCT</td> <td></td> <td></td> <td></td> <td>✓</td> </tr> <tr> <td></td> <td>0 611 975 A1</td> <td>2/22/89</td> <td>Europe</td> <td></td> <td></td> <td></td> <td>✓</td> </tr> </tbody> </table>								REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Trendline		YES	NO		DE 196 02 079 C1	5/15/97	Germany				✓		DE 195 42 658 A1	5/22/97	Germany				✓		WO 00/28362	5/18/00	PCT				✓		WO 96/22177	7/25/96	PCT				✓		0 611 975 A1	2/22/89	Europe				✓
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EXAMINER <i>Ahsen Enayetullah</i>		DATE CONSIDERED 12/8/03																																																							
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